

Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/588,091	STENCIL, JOHN M.
	Examiner	Art Unit
	Helen C. Kwok	2856

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
73	589	3/17/2010	HK
73	60.11	3/17/2010	HK
73	64.41	3/17/2010	HK